



First Named Inventor	Kyle K. Kirby	INFORMATION DISCLOSURE STATEMENT FORM PTO-1449
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Examiner Initials	Document No.	Issue/Publication Date	Name	Filing Date
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Examiner Signature	<i>Stephen W. Smoot</i>	Date Considered	July 22, 2004
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			